

RD-27190-3

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of  
Barry Lee-Mean Yang et al.

: Group Art Unit No.: 1762

Serial No. 10/063,094

: Examiner: T. Meeks

Filed March 19, 2002

For APPARATUS AND METHOD  
FOR LARGE AREA CHEMICAL  
VAPOR DEPOSITION USING  
MULTIPLE EXPANDING  
THERMAL PLASMA  
GENERATORS

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ASSOCIATE POWER OF ATTORNEY

Honorable Assistant Commissioner for Patents,

The undersigned, Tanzina S. Chowdhury having been appointed  
attorney-of-record in the above-identified application hereby appoints

Robert P. Santandrea Registration No. 45,072

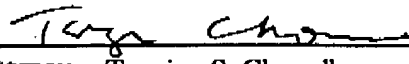
associate attorney with full power of delegation, substitution and revocation, to prosecute the  
above-identified application and to transact all business in the Patent and Trademark Office  
concerned therewith, and directs that all correspondence in connection with said application be  
addressed to:

General Electric Company  
CRD Patent Docket Rm 4A59  
P.O. Box 8, Bldg. K-1  
Schenectady, New York 12301

Respectfully submitted,

Schenectady, New York

Date

3/5/04  
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Registration No. 46,624

(CRD 2/96)